

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Daniel MEISEL et al.

International Appln: PCT/EP2003/007819

U.S. Application No.: Not Yet Assigned

For: METHOD FOR THE PRODUCTION
OF PHOTORESIST STRUCTURES

Art Unit: Not Yet Assigned

Examiner: Not Yet Assigned

Confirmation No.: Not Yet Assigned

Atty. Docket No.: 31775-210910 RKCustomer No.: **26694**

X3

Information Disclosure Statement

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is an Information Disclosure Statement submitted under 37 C.F.R. § 1.97 within the time specified under 37 C.F.R. § 1.97(c).

In order to comply the duty of disclosure pursuant to 37 C.F.R. § 1.56, submitted herewith is a Form PTO/SB/08A listing the documents cited in the International Search Report of International Application No. PCT/EP2003/007819. Document AG is listed on the attached Form PTO/SB/08A and is enclosed, which the Examiner may deem relevant to patentability of the claims of the above-identified application. The relevance of each document is indicated therein.

Copies of the documents cited in the International Search Report are not being provided since copies are furnished directly by WIPO under an exchange program between the PTO, the EPO and the JPO.

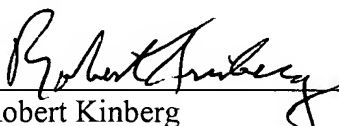
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Applicant(s): Daniel MEISEL et al.
Atty. Docket: 31775-210910 RK

In view of the above, no further statement of relevance need be given, and as all requirements of 37 C.F.R. § 1.97 and § 1.98, and all official guidelines pertaining to Information Disclosure Statements have been complied with, it is respectfully requested that the Examiner consider the cited publications and make them of record.

Respectfully submitted,

Date: January 24, 2005


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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet **2** of **2**

Complete if Known

Application Number	NOT YET ASSIGNED 09/522 162
Filing Date	Concurrently
First Named Inventor	Daniel MEISEL et al.
Group Art Unit	Not Yet Assigned
Examiner Name	Not Yet Assigned
Attorney Docket Number	31775-210910 RK

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	AG	Chaitanya K. ULLAL et al., "PHOTONIC CRYSTALS THROUGH HOLOGRAPHIC LITHOGRAPHY: SIMPLE CUBIC, DIAMOND-LIKE, AND GYROID-LIKE STRUCTURES," Applied Physics Letters, 28 June 2004, Pages 5434-5436, Vol. 84, No. 26	

Examiner Signature		Date Considered	
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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